

EAST Search History

EAST Search History (Prior Art)

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|--|-----------------|------------------|---------|------------------|
| S108 | 1441 | 703/13.ccls. | USPAT | OR | OFF | 2011/07/25 11:54 |
| S109 | 2069 | 703/13.ccls. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:54 |
| S110 | 936 | 703/7.ccls. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:54 |
| S111 | 809 | 438/5.ccls. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:54 |
| S112 | 0 | S111 and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment))) with (distributed adj simulat\$4)).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:55 |
| S113 | 4 | S111 and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment))).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:56 |
| S114 | 0 | S111 and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment))) with (((re adj use)lookup) with result solution)).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:57 |
| S115 | 0 | S109 and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment))) with (((re adj use)lookup) with result solution)).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:57 |
| S116 | 0 | S110 and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment))) with (((re adj use)lookup) with result solution)).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:57 |
| S117 | 0 | (S109 OR S110) and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment))) with (distributed adj simulat\$4)).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:57 |
| S118 | 916 | (S109 S110 S111) and ((model\$4 simulat\$4) with (grid mesh\$4 element)) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:58 |
| S119 | 118 | (S109 S110 S111) and ((model\$4 simulat\$4) with (grid mesh\$4 element) with (geometr\$4)) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:59 |
| S120 | 2858 | 700/121.ccls. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 11:59 |
| S121 | 0 | S120 and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment))) with (distributed adj simulat\$4)).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:00 |
| S122 | 55 | S120 and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment))).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:00 |
| S123 | 0 | S120 and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:01 |

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|------|------|---|-----------------|----|-----|------------------|
| | | manufactur\$4 equipment)) with (((re adj use)lookup) with result solution)).clm. | | | | |
| S124 | 156 | ((S120) and ((model\$4 simulat\$4) with (grid mesh\$4 element))) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:01 |
| S125 | 8 | ((S120) and ((model\$4 simulat\$4) with (grid mesh\$4 element) with (semiconductor near2 (tool assembly manufactur\$4 equipment)))) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:02 |
| S127 | 0 | ((S109 S110 S111 S120) and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (((re adj use) lookup) with result solution)).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:04 |
| S128 | 627 | ((STRANG).inv. OR (MITROVIC).inv. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:05 |
| S129 | 162 | ((ERIC near2 STRANG).inv. OR (ANDREJ near2 MITROVIC).inv. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:06 |
| S130 | 9 | ((S109 S110 S111 S120) and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (grid cell geometr\$4 (physical adj geometr\$4))).clm. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:11 |
| S131 | 2 | ((700/29-31.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (grid mesh element))) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:14 |
| S132 | 1 | ((700/29-31.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (distribut\$4 with (model\$4 simulat\$4 execut\$4)))) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:14 |
| S133 | 8 | ((438"/\$.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (distribut\$4 with (model\$4 simulat\$4 execut\$4)))) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:15 |
| S134 | 0 | ((700/95.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (grid mesh element))) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:16 |
| S135 | 899 | ((700/95.ccls. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:17 |
| S136 | 1431 | ((703/22.ccls. | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:17 |
| S137 | 79 | ((semiconductor near3 (process\$4 too154 equipment manufactur\$4)) and ((model\$4 simulat\$4) with((physical geometry) near2 (machine tool manufactur\$4 assembly))) and ((parallel near3 process\$4) (code adj parallel\$8) ((plural distributed multiple) near4 simulat\$4) and grid) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:18 |
| S138 | 0 | ((semiconductor near3 (process\$4 too154 equipment manufactur\$4)) and ((model\$4 simulat\$4) with ((physical geometry) near2 (machine tool manufactur\$4 assembly))) and (("re" adj (using use)) with (known start\$4 precomputed stor\$4) with (result solution output)) | US-PGPUB; USPAT | OR | OFF | 2011/07/25 12:22 |

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|------|----|--|--|----|-----|------------------|
| S139 | 0 | (semiconductor near3 (process\$4 too154 equipment manufactur\$4)) and ((model\$4 simulat\$4) with ((physical geometry) near2 (machine tool manufactur\$4 assembly))) and (("re" adj (using use)) with (known start\$4 precomputed stor\$4) with (result solution output)) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2011/07/25 12:22 |
| S140 | 15 | (semiconductor near3 (process\$4 too154 equipment manufactur\$4)) with ((model\$4 simulat\$4) with ((physical geometry) near2 (machine tool manufactur\$4 assembly))) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2011/07/25 12:23 |
| S148 | 29 | US-5526293-\$.DID. OR US-5583780-\$.DID. OR US-5866437-\$.DID. OR US-6304834-\$.DID. OR US-20020107604-\$.DID. OR US-20030078738-\$.DID. OR US-20030101251-\$.DID. OR US-6571371-\$.DID. OR US-6560503-\$.DID. OR US-20030135302-\$.DID. OR US-6587744-\$.DID. OR US-6628809-\$.DID. OR US-6643616-\$.DID. OR US-20040078319-\$.DID. OR US-6728591-\$.DID. OR US-20040102934-\$.DID. OR US-6757645-\$.DID. OR US-6763277-\$.DID. OR US-6774998-\$.DID. OR US-6810296-\$.DID. OR US-6812045-\$.DID. OR US-20050010319-\$.DID. OR US-20050016947-\$.DID. OR US-6905895-\$.DID. OR US-7055112-\$.DID. OR US-7184850-\$.DID. OR US-7333871-\$.DID. OR US-7356377-\$.DID. OR US-7622308-\$.DID. | US-PGPUB; USPAT | OR | OFF | 2011/07/26 12:28 |

EAST Search History (Interference)

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|-------------|------------------|---------|------------------|
| S141 | 0 | 438/5.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (distributed adj simulat\$4)).clm. | USPAT; UPAD | OR | OFF | 2011/07/25 12:25 |
| S142 | 0 | 438/5.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (((re adj use) lookup) with result solution)).clm. | USPAT; UPAD | OR | OFF | 2011/07/25 12:26 |
| S143 | 0 | 438/5.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (((re adj use) lookup) with result solution)).clm. | USPAT; UPAD | OR | OFF | 2011/07/25 12:26 |
| S144 | 0 | 703/7,13,22.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (((re adj use) lookup) with result solution)).clm. | USPAT; UPAD | OR | OFF | 2011/07/25 12:26 |
| S145 | 0 | 703/7,13,22.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (((re adj use) lookup) with result solution)).clm. | USPAT; UPAD | OR | OFF | 2011/07/25 12:27 |
| S146 | 0 | 703/7,13,22.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly | USPAT; UPAD | OR | OFF | 2011/07/25 12:27 |

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|------|---|---|----------------|----|-----|---------------------|
| | | manufactur\$4 equipment)) with (((re adj use) lookup) with result solution)).clm. | | | | |
| S147 | 0 | 700/121.ccls. and ((model\$4 simulat\$4) with (semiconductor near2 (tool assembly manufactur\$4 equipment)) with (((re adj use) lookup) with result solution)).clm. | USPAT; UPAD | OR | OFF | 2011/07/25 12:27 |

7/ 26/ 2011 2:48:56 PM
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